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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Confirmation No.: Unknown

Group Art Unit: 1725

Filed: February 20, 2001

Examiner: Unknown

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For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING, AND AN
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Prior to examination, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Amend the specification by inserting before the first line the sentence:

This is a continuation application of PCT Patent Application PCT/JP99/02379, filed May
7, 1999, which was published in Japanese.

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